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Complete if Known

U/517657

<p>Application Number</p> <p>Confirmation Number</p> <p>Filing Date</p> <p>First Named Inventor</p> <p>Art Unit</p> <p>Examiner Name</p> <p>Attorney Docket Number</p>				<p>Not yet assigned</p> <p>Not yet assigned</p> <p>December 13, 2004</p> <p>Enzo DI FABRIZIO</p> <p>Not yet assigned</p> <p>Not yet assigned</p> <p>Q85169</p>	
Sheet	1	of	1		

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		Number	Kind Code ² (if known)		
		US 2002/050711	A1	05/2/2002	Waiti, et al.
		US 2002/022682	A1	09/20/2001	McClelland
		US 5,487,012		01/23/1996	Tophelm et al.

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Translation ⁶
		Country Code ³	Number ⁴	Kind Code ⁵ (if known)			
		BE	1 010 200	A	03/03/1998	Variphone Benelux Naamloze Ven	
		WO	02/091920		11/21/2002	OTICON AS	

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation ⁶
		Xie Huikai et al.: "A SCS SMOS Micromirror for Optical Coherence Tomographic Imaging" Technical Digest., MEMS 2002 IEEE International Conference on Micro Electro Mechanical Systems, Las Vegas. NV, USA, January 20, 2002-January 24, 2002, pages 495-498, XP010577701, Piscataway, NJ, USA, ISBN: 0-7803-7185-2, pages 497-487, section "OCT application" abstract	
		J. Micromech. Microeng. 13, 2003, pages 383-389	

Examiner Signature		Date Considered	
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